E. Compound Semiconductors 분과

2017년 2월 15일 (수), 15:25-17:10 Room D (크리스탈, 2층)

[WD4-E] WBG Chharacterization Technology

좌장: 장우진(한국전자통신연구원), 김정진(전북대학교)

	Effect of TMAH Surface Treatment on AlGaN/GaN HEMT
WD4-E-1 15:25-15:40	Won-Sang Park, Do-Kywn Kim, Dong-Hyeok Son, Chul-Ho Won, Jun-Hyeok Lee, Ki-Sik Im, and Jung-Hee Lee School of Electrical Engineering, Kyungpook National University
	Effects of Passivation Layers on Carrier Transport in AlGaN/GaN HFETs
WD4-E-2 15:40-15:55	Sejoon Oh, Taehoon Jang, and Jaehee Cho School of Semiconductor and Chemical Engineering, Semiconductor Physics Research Center, Chonbuk National University
WD4-E-3 15:55-16:10	Characterization of Heterojunction Interface Traps in AlGaN/GaN HEMTs through Sub-Bandgap Photonic Response and Subthreshold Ideality Factor Jaewon Kim ¹ , Heesung Lee ¹ , Hagyoul Bae ² , Ogyun Seok ³ , Sung-Jun Choi ¹ , Dae Hwan Kim ¹ , and Dong Myong Kim ¹ ¹ School of Electrical Engineering, Kookmin University, ² School of Electrical Engineering, KAIST, ³ Korea Electrotechnology Research Institute
WD4-E-4 16:10-16:25	Leakage Current Reduction of Gated Ohmic Anode AlGaN/GaN Schottky Barrier
	Diode by Applying Anode Edge Termination
	Ra-Seong Ki ¹ , Min-Woo Kong ¹ , Jun-Seok Jung ¹ , Ho-Young Cha ² , and Kwang-Seok Seo ¹ ¹ Department of Electrical Engineering and Computer Science, Seoul National University, ² Department of Electronic and Electrical Engineering, Hongik University
WD4-E-5 16:25-16:40	Current Collapse-Free AlGaN/GaN Nanowire Gate-All-Around FETs
	Chul-Ho Won, Sindhuri Vodapally, Ki-Sik Im, and Jung-Hee Lee School of Electronics Engineering and Institute of Semiconductor Fusion Technology, Kyungpook National University
WD4-E-6 16:40-16:55	Photoresist Removal on GaAs Surface Using Organic Solvents
	Eunseok Oh, Sehyun Oh, Junwoo Lee, and Sangwoo Lim Department of Chemical and Biomolecular Engineering, Yonsei University
	High-Performance In _{0.53} Ga _{0.47} As-OI MOSFET on Si Substrates
WD4-E-7 16:55-17:10	Seong Kwang Kim ^{1,2} , Jae-Phil Shim ¹ , Dae-Myeong Geum ^{1,3} , Chang Zoo Kim ⁴ , Han-Sung Kim ¹ , Yeon-Su Kim ¹ , Hang-Kyu Kang ¹ , Jin-Dong Song ¹ , Sung-Jin Choi ² , Dae Hwan Kim ² , Won Jun Choi ¹ , Hyung-jun Kim ¹ , Dong Myong Kim ² , and SangHyeon Kim ¹ ¹ Korea Institute of Science and Technology, ² School of Electrical Engineering, Kookmin University, ³ Department of Materials Science and Engineering, Seoul National University, ⁴ Korea Advanced Nano Fab Center